01/24/02

Docket No. A5597/T41100

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application Commissioner of Patents and Trademarks Washington, D.C. 20231

Re:

Inventor(s): Padmanabhan Krishnaraj et al.

Title:

IN SITU APPLICATION OF ETCH BACK FOR IMPROVED DEPOSITION INTO HIGH-ASPECT-RATIO

FEATURES

Transmitted herewith is the patent application identified above, including:

X Specification, claims and abstract, totaling 22 pages.

Application Data Sheet

Drawings totaling <u>3</u> pages, <u>Formal X</u> Informal.

Combined Declaration and Power of Attorney.

Assignment of the invention to Applied Materials, Inc.

Assignment Recordation Cover Sheet

Information Disclosure Statement and copies of 16 cited references

FEE	CAI	LCU.	LAT	ION
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Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total		
Total Claims	23	-20=	3	X\$18.00	\$ 54.00		
Independent Claims	6	-3=	3	X\$84.00	\$ 252.00		
Basic Filing Fee				\$740.00	\$. 740.00		
TOTAL FEES					\$1,046.00		

XX The Commissioner is hereby authorized to charge \$1,046.00 to Deposit Account No. 50-1074.

XX The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

XX Please address all future correspondence to:

PATENT COUNSEL

APPLIED MATERIALS, INC.

Legal Affairs Department

P.O. BOX 450A

Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D.C. 20231

Express Mail Receipt No

EV049834243US

Robert W. Mulcahy

Registration No. 25,436

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Date of Deposit